IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of:

Tony Kroeker

Serial No.: Unknown

Filed:

Herewith

Continuation of Serial No. 09/161,970

Continuation Filed: Sept. 28, 1998

For: Single Wafer Load Lock With

Internal Wafer Transport

Assistant Commissioner of Patents Washington, D.C. 20231

Dear Sir:

Group Art Unit:

Unknown

Examiner:

Unknown

CERTIFICATION UNDER 37 CFR 1.10

I hereby certify that this correspondence is being deposited with the United States Postal Service on this date, in an envelope as "Express Mail Post Office to Addressee," mailing label no. <u>EL704518435US</u>, addressed to: Assistant Commissioner for Patents, Box PATENT APPLICATION, Washington, D.C. 20231.

6-4-01

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PRELIMINARY AMENDMENT

Prior to examination of the above referenced application, the Applicant requests that the application be amended as follows:

In the claims:

Please cancel claims 1-45, without prejudice, and add the following claims:

46. (I

- 46. (New) A semiconductor processing system, comprising:
 - a pod loader;
 - a mini-environment having a robot disposed therein;
 - one or more load lock chambers connected to the mini-environment; and
- one or more process chambers connected to the one or more load lock chambers, wherein each load lock chamber is connected to a single process chamber.
- 47. (New) The system of claim 46, wherein each load lock chamber comprises: an enclosure having a bottom, a lid and sidewalls defining a chamber cavity; and